

GAS CONDENSATE PUT - Depletion Recovery

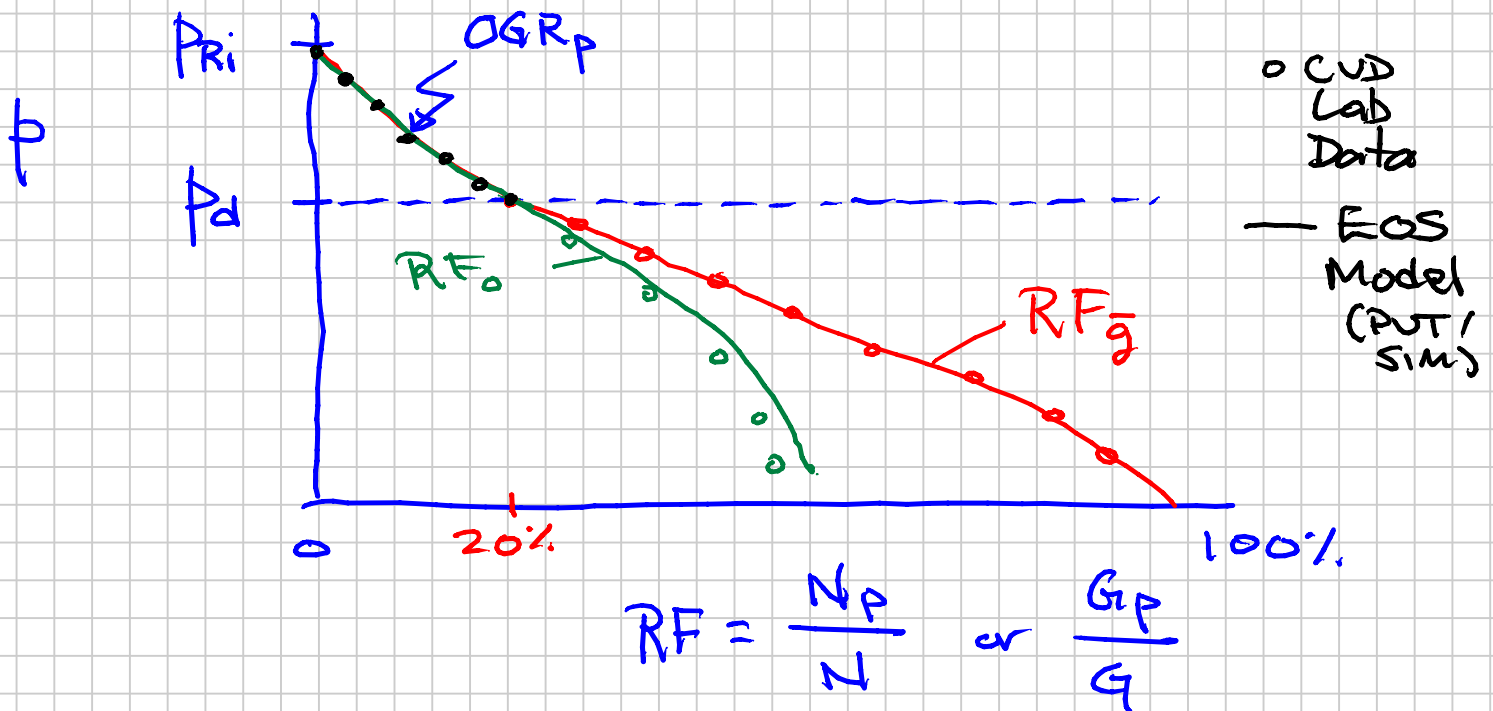
Note Title

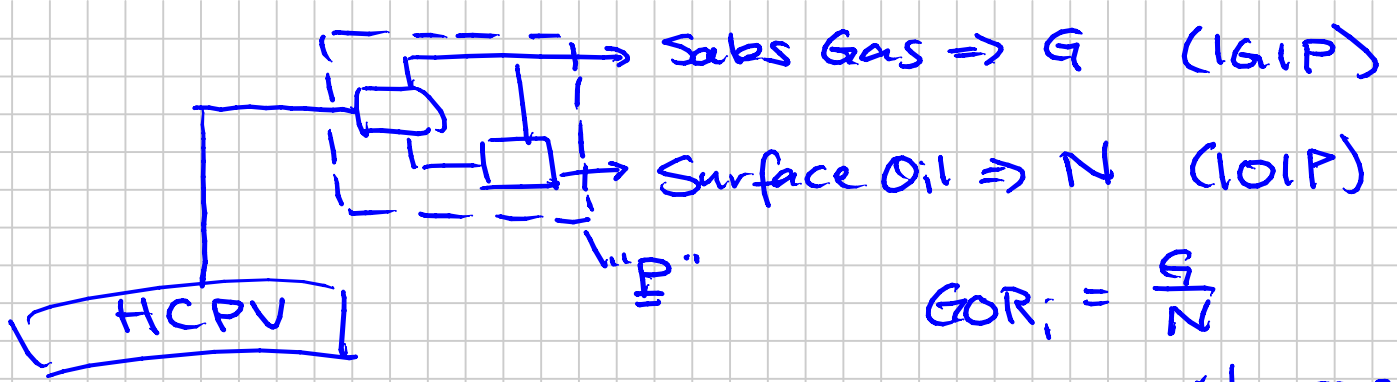
2012-02-24

- EOS-based PUT Model
 - Defined consistently between the PUT simulator & Reservoir simulator
- Surface Process
 - Defined consistently between the PUT simulator & Reservoir simulator

If done properly then:

- Same initial GOR (OGR)
- Same (\sim line thickness) $RF_o(p) \approx RF_g(p)$ for depletion (Phase Comp)
 - CVD test for PUT simulator
 - Depletion for Reservoir simulator (SENSOR)





$$GOR_i = \frac{G}{N}$$

$$OGR_i = \frac{N}{G} \frac{STB}{MMscf}$$

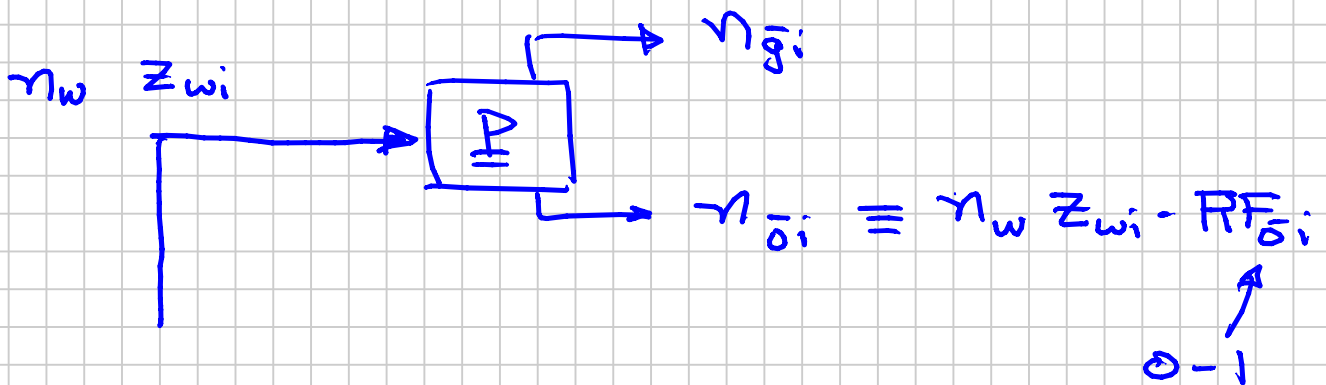
$$\underline{P_{ri} \rightarrow P_d} : \frac{G_p^*}{G} = 0.2$$

$$N_p = \int_{P_{ri}}^{P_d} OGR_p dG_p = OGR_i \cdot G_p^*$$

$$OGR_p = OGR_i \text{ for } P_r \geq P_d$$

$$RF_{oi} = \frac{N_p}{N} = \frac{G_p \cdot OGR_i}{G \cdot OGR_i} = RF_{gi}$$

II: Component Liquid RF_{oi}



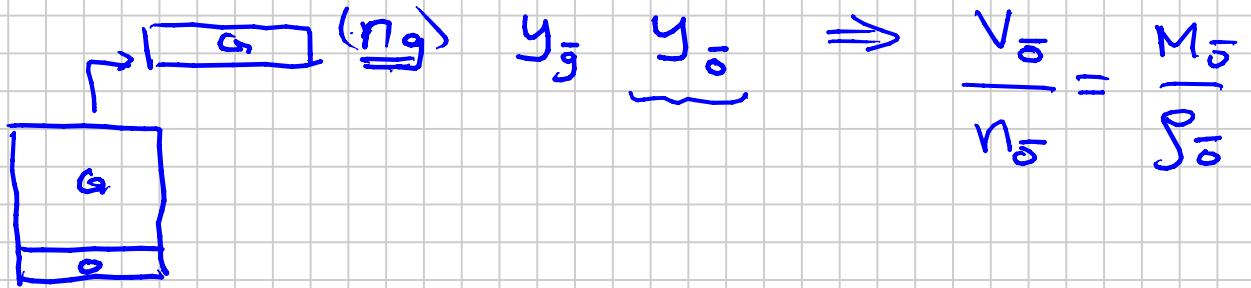
$$n_{gi} \cdot 379 \frac{\text{scf}}{\text{lb-mole}}$$

$$GOR = \frac{n_{gi} \cdot 379 \frac{\text{scf}}{\text{lb-mole}}}{n_{oi} \cdot \left(\frac{M_{oi}}{\rho_{oi}}\right) \cdot \frac{1 \text{ STB}}{5.615 \text{ ft}^3}}$$

$$= 2140 \frac{n_g}{n_o} \left(\frac{p_o}{M_o} \right) \text{CVD Gas} : 2128 \frac{y_g}{y_o} \quad (1)$$

$$= 2128 \frac{y_g}{y_o}$$

Wellstream from CVD test



$$(M_o)_g = \frac{\sum (y_i R F_{oi}) M_i}{\sum y_i R F_{oi}}$$

$$(V_o)_g \equiv \frac{\sum (y_i R F_{oi}) M_i}{\sum \left(\frac{y_i R F_{oi} M_i}{S_{Li}} \right)}$$

$$(p_o)_g \equiv \frac{\sum (y_i R F_{oi}) M_i}{\sum \left(\frac{y_i R F_{oi} M_i}{S_{Li}} \right)}$$

$$= \frac{\sum \left(\frac{y_i R F_{oi} M_i}{S_{Li}} \right)}{\sum y_i R F_{oi}}$$

Sum of masses

Sum ideal liquid volumes



$$GOR = 2128 \cdot \frac{1 - 0.0659}{0.0659} \left(\frac{0.781 (62.4)}{133.66} \right)$$

$$= 11000 \text{ scf/STB} \quad \text{vs} \quad 11014$$

$$IGIP (G) \in IGIP (N) \quad \checkmark \quad GOR_i \checkmark$$

$$n = 6.5061 \cdot 10^7 \text{ lb-moles}$$

RF ₀	RF _g	P _r	
32.5	47.0	2011	K=100
33.1	46.8	2021	K=1000
33%	47%	2000	EOS Simulator

